

IFU

Serial No. 10/655,305
SEC.1080



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :
Yong-Sung HONG : Group Art Unit 3723
Serial No. 10/655,305 : Examiner S. McDonald
Filed September 5, 2003 :

CMP EQUIPMENT FOR USE IN PLANARIZING A SEMICONDUCTOR
WAFER

AMENDMENT

U.S. Patent and Trademark Office
220 20th Street, South
Customer Window, **Mail Stop Amendment**
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

In response to the Office action of July 27, 2004, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 5 of this paper.